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METHOD FOR GRAFTING A CHEMICAL COMPOUND TO A SUPPORT SUBSTRATE

The invention relates to a method for grafting a chemical compound to a predetermined region of a support substrate.

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Rapid and simple methods for creating micro- and nanostructured surfaces or three-dimensional structures, such channels, tubes or in the support substrate are desirable. These micro- and nano-structured surfaces or three-dimensional structures have designed features. structures or aspects with lateral or vertical dimensions on the order of from one nanometer to several microns. To allow these structures a broad field of applications, it is desired that these micro- and nano-structured surfaces made having a wide varietv of chemical functionalities and physical properties. Properties of interest include reactivity or binding characteristics towards particular chemical species or hydrophobic hydrophilic properties. It is further desirable to create these structures having functionalities or properties structured in the form of micro-scale nanoor arrays or other geometric structures. For example, such micro- and nano-structured application materials find in can combinatorial chemistry, (bio)-sensing, membrane technologies, repellents, adhesives, lubricants, anti-fogging coatings, and micro- and nano-electronic and magnetic devices. Alternatively, they can be used to create biologically compatible surfaces or to offer medical or biotechnological active surfaces.

One form of such suitable materials are known as "polymer 35 brushes", and they are described, for example, by Freemantle in Chemical & Engineering News, April 14, 2003, p. 41-45. In these materials polymer chains are tethered at one end, usually by covalent bonding, to a

surface or an interface. Such polymer brushes can be made by the "grafting-to" or "grafting-from" methods. The grafting-to method involves the reaction of preformed polymer chains with a surface to anchor the chains on the surface. The grafting-to method has the disadvantage of giving surfaces with only low grafting densities (number of polymer chains/unit area). In particular, polymer chains at the interface of a solution and substrate are in the form of brushes only if the grafting density is high enough to force the chains to adopt elongated rather than coiled conformations.

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In grafting-from method, initiator molecules immobilized on a surface and exposed to a monomer under appropriate polymerization conditions. The grafting-from currently suffers from the disadvantages requiring multiple steps for creating, activating, and reacting initiator sites, and they are typically created only on comparably expensive special gold or silicon surfaces. example of An such reaction a scheme disclosed from U. Schmelmer and co-workers Chem. Int. Ed. 42, No. 5 (2003) 559-563, especially in Figure 1 of this disclosure.

In view of the several afore mentioned drawbacks of the actually known methods, it would be a desired aim of the invention to have simpler methods involving less preparation steps and common and inexpensive reagents, processes, and substrates. In particular, it would be desirable to be able to use common polymers as flexible and extrudable, moldable or castable substrates.

This aim is achieved according to the present invention by a method for grafting a chemical compound to a predetermined region of a support substrate, comprising:

a) irradiating selectively the support substrate with electromagnetic radiation and/or particle radiation in order to both define said predetermined region

and to form at least one reactive functional group or a precursor thereof in said predetermined region of the support substrate;

b) exposing the irradiated support substrate to said chemical compound or to a precursor thereof.

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Therefore, only these very few steps are needed effectively grafting the desired chemical element or compound, such as an organic compound, to the predetermined regions of the support substrate. Moreover, the irradiation step can be carried out in a vastly flexible manner and allows to generate numerous distinct shapes of the predetermined regions. Further, micro- or nano-scale regions in the support substrate capable of forming reactive functional groups or precursor thereof upon exposure to particle or electromagnetic irradiation can be easily achieved. Thereby, in view of the above mentioned invention, reactive a functional considered as being any modified structural unit generated by the irradiating step that is able to act as a reactive site for the chemical compound to be grafted thereupon.

The step of exposing can be a simultaneous or subsequent step, when the irradiated support substrate is exposed preferably to one or more radically polymerizable monomer The physical properties, height, penetration depth and spatial resolution of the micro- or nano-scale modification of the support substrate can be conveniently varied by controlling the various parameters in irradiation or exposing steps. There is no specific limitation as to the substrate depth that is modified. The modification can be primarily just on the surface or extend through the entire thickness of the substrate. Examples of these parameters in the irradiation process include the type and energy of the radiation, the total dose, the dose rate and the irradiation atmosphere.

With respect to the type of the support substrate used in invention there does not exist any specific limitations. Any organic or inorganic substrate capable of forming reactive functional groups upon exposure to ionizing irradiation are suitable. The composition and chemical structure of the substrate is also not limited. The substrate will generally be selected according to the desired properties for the substrate, for mechanical properties, or according to the desired for properties the non-structured regions such hydrophilic or hydrophobic or reactive or inert. non-limiting examples of substrates include polymers such fluoropolymers like PTFE, FEP, PVDF or polyolefins like polyethylene or polypropylene. Additionally, even the form of the substrate is specifically limited and includes coatings, films, shaped particles.

With respect to the reactive functional group dealing as the receptor nuclei for the latter grafting a nonlimiting number of examples for the reactive functional groups introduced by the irradiation can be mentioned. These examples include hydroperoxides, peroxides or such radical species as alkyl, oxy, or peroxy radicals.

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Referring to the type of radiation used to generate the reactive functional groups in this invention again no reasonable specific limitation is in sight. Radiation may include electromagnetic radiation like UV or X-rays or particle radiation such as electron beam. In particular, the irradiation energy and type can be varied to control the depth of functionalization of the latter micro- or nano-grafting into the support substrate. For example, the wavelength of the electromagnetic radiation accelerating potential for the electron beam will have a strong influence on the penetration depth as it can be derived from physical penetration theory. The wavelength also determines the minimum spatial resolution

patterning. The total dose and dose rate influence the total number and thus density of reactive sites (reactive functional groups) formed.

- 5 Furthermore, the irradiation atmosphere can be controlled to yield oxygen-containing or other element-containing reactive sites in the substrate. In some cases a vacuum or inert irradiation atmosphere might be selected in order to minimize degradation of the support substrate.
- 10 In the case of polymeric substrates, the irradiation conditions can be selected in order to preferentially bring about crosslinking or chain scission or even ablation of the polymer substrate.
- 15 However, masks or stencils and interference or projection lithography or other methods known in the prior art can be used to create the micro- or nano-scale pattern of reactive sites on and/or in the support substrate.
- The method used to micro- or nano-graft the substrate is not specifically limited. For example, the grafting can be carried out simultaneously along with the irradiation process, or the grafting can be done in a post-irradiation step. If the grafting is done in a subsequent step, the irradiated substrate may be stored at room temperature or at reduced or at elevated temperature and/or under inert atmosphere if the reactive sites are unstable.
- Parameters in the grafting process can be varied in order 30 to optimize the resolution of the grafting process. For example, the sharpness and height of the grafted microor nano-regions can be enhanced or controlled by proper selection of the monomer concentration orgrafting 35 temperature. Other parameters such as the choice of solvent or the use of chain-transfer or terminating agents or living polymerization agents or methods can also be used to influence these properties.

The physical form of the monomer is also not specifically limited in this invention. For example, the monomer may be applied to the substrate in the form of a gas or a liquid, and the monomer may be either pure or diluted with a solvent or inert material and/or as a mixture with one or more additional monomers. Any radically active monomer may be used in this invention including vinyl, styrenic or acrylic monomers. Monomers can be selected in invention according to the properties that desired for the microor nano-structured regions. For example, if it is desired that the grafted region be hydrophilic in nature, monomers having polar or hydrogen bonding functional groups such as amine, amide, thiol, hydroxy, carboxyl, carboxylic acid, or ester may be selected. Further non-limiting examples of hydrophilic monomers include acrylic acid and its salts, methacrylic acid and its salts, methyl methacrylate, sulfonated styrene and its salts, styrene sulfonic acid and its salts, or vinyl sulfonic acid. If the grafted regions should hydrophobic, be fluorinated or hydrocarbon can be used. Non-limiting examples include styrene, ethylene, propylene, and tetrafluoroethylene. In another embodiment of the current invention, monomers having specific functional groups useful for binding of target species are used.

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The modified grafted regions in the support substrates are characterized in that they are micro- or nano-scale regions, either substantially 2-dimensional or 3dimensional, that contain the grafted polymer chains. There is no specific limitation on the shape or form of these grafted regions, and for example, they may dots, grids, mesh, stenciled, channels, tubes, cylinders or any other suitable arbitrary geometric shapes. These grafted regions may be either nanomicrometer scale in height. With reference to the afore mentioned 3-dimensional shape, the grafted regions may also penetrate into the interior of the modified material and/or may be detached from the surface in a subsequent step.

5 Without any limitation to any application a person skilled in the art may have apparently understood from the description, the application of these micro- or nanografted materials is proposed for use in the fields of combinatorial chemistry, membrane technology, surface 10 science (including repellents, adhesives and lubricants anti-fogging and other coatings), sensing, information storage, chromatography, separation processes, electrochemical synthesis, medical and biotechnical material handling, electrochemical energy 15 storage and conversion devices, and electronic magnetic devices. A person skilled in the art will be to select substrates, chemical elements compounds, and predetermined regions appropriate for any of these applications. A non-limiting example is a micro-20 or nano-grafted material modified through its thickness with functional groups useful for the conduction of ions other species. Non-limiting examples functional groups include acids, bases, or amphoteric groups.

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The various features and advantages of this invention will become apparent to those skilled in the art from the following detailed description of the currently preferred embodiment. The drawings that accompany the detailed description can be briefly described as follows:

Figure 1 is a 100 µm ETFE-film as received;

Figure 2 is a 100 µm ETFE-film, flattened at 230°C;

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Figure 3 is a 100 μm ETFE-film, flattened at 230°C, electron beam exposed (line ``la) and grafted with 10% acrylic acid for 20 min;

Figure 4 is a 100 µm ETFE film, flattened at 230°C, X-ray exposed (exposure 1, box 1) and grafted with 5% acrylic acid; and

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Figure 5 is a 100 μm ETFE-film, flattened at 230°C, X-ray exposed (interference set-up, period: 100 nm) and grafted with 5% acrylic acid for 15 min at 50°C.

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For the examples, Nowoflon ET-6235 films having thicknesses of 25, 50, and 100 μm and extruded roll widths of 155 cm designated here as N-25, N-50, N-100 were purchased from Nowofol GmbH, Siegsdorf, Germany. The average molar weight of the Dyneon ET 6235 copolymer used to make these films is approximately 400,000 Dalton.

To obtain a flat test surface, a piece of ETFE film 2

(Nowoflon ET-6235, 100 µm, "N-100") was placed between two polished 4'' silicon wafers, or 2.5 x 2.5 cm² pieces thereof. In a hot press which is optimised for nano-imprint lithography, this sandwich was heated for 5' at 230 °C under a pressure of 200-2500 N/cm². The procedure results in a reduction of film thickness of about 5-10%, and a drastic reduction in surface roughness as it can be seen from the comparison of the initial ETFE film 2 and the flattened ETFE film 4 in the figures 1 and 2.

30 Electron beam exposures were done with a LION-LV1 e-beam system (Leica Microsystems, Jena, Germany). The beam energy was 2.5 keV. The "continuous path control" mode was used to obtain lines with the desired doses in our exposures. The beam defocus was adjusted to control the exposed linewidth.

X-ray exposures were done at the "X-ray Interference Lithography" beamline of the Swiss Light Source. The beamline uses undulator light with a central wavelength eV) (92 and approximately 2% bandwidth. The incident x-ray power on the sample was several mW/cm2 and the delivered dose was controlled with a fast beam shutter. A shadow mask in proximity to the sample to define the exposed areas on the sample. A TEMgrid with features in the range of > 50 µm was used as a shadow mask in proximity to the sample to define the exposed areas in the sample. X-ray interference exposures were done described as by Harun Solak Microelectronics Engineering 67-68 (2003) 56.62.

Pieces of micro- or nano-scale irradiated ETFE films were placed in small glass tube reactor equipped with purge gas inlets and outlets that can be sealed by means of stopcocks. The reactor is then filled with an aqueous solution of acrylic acid monomer and then closed. After purging the reactor for 1 hr with nitrogen, the reactor is sealed by first closing the outlet, and then the inlet. The reactor was then placed in a water bath preheated to the desired reaction temperature. When the reaction time is over, the reactor seal is broken and the sample is gently taken out of reactor. The sample was then rinsed four times with deionised water and then dried at room temperature.

The following reaction conditions were used:

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	Acrylic Acid conc./%	Temperature/°C	Reaction Time/min
1.	10	60	20
2.	5	60	20
3.	5	50	15

30 grafted The samples were inspected optical in an microscope and characterized using atomic force microscopy (AFM). Α Digital Instrument Nanoscope III

(Dimension 3100) was used in the tapping mode using Nanosensor NCH type AFM tips with a resonance frequency of 330 kHz.

- 5 First measurements on e-beam exposed and grafted samples were conducted at the PSI as well as first characterization of X-ray exposed (shadow mask and interference set-up) and grafted samples.
- 10 Figure 3 shows a typical AFM image of a line structure 6 produced by e-beam irradiation and grafting. The line width is depending on the defocus of the e-beam (which is not yet optimized for the used material) and on the dose supplied. Using the 10% acrylic acid solution to graft a sample exposed to low dose, a structure with a very sharp definition of the borders and a height in the range of 150 nm was obtained. Control measurements of a sample with the same e-beam exposure but without grafting showed no significant change in surface texture. In contrast, at high e-beam doses a significant milling of the surface was observed (data not shown.)

Flattened ETFE 4 was exposed to various doses of x-rays through a TEM grid used as a shadow mask. After grafting with 5% acrylic acid, the structures (\geq 50 µm) were clearly visible in the optical microscope. The height of the grafted structures 8 as measured with the AFM (Figure 4) was in the range of 300 nm with very little dependence on the used dose of x-rays.

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The AFM image (Fig. 5) of a sample which was irradiated in the x-ray interference set-up and grafted with 5% acrylic acid shows a pattern with a period of 100 nm.

35 The foregoing description is exemplary and not just a material specification. The invention has been described in an illustrative manner, and should be understood that the terminology used is intended to be in the nature of

words of description rather than of limitation. modifications and variations of the present invention are possible in light of the above teachings. The preferred embodiment of this invention have been disclosed, however, one of ordinary skill in the art would recognize that certain modifications are within the scope of the invention. It is understood that within the scope of the appended claims, the invention may be practiced otherwise than as specifically described. For that reason, the following claims should be studied to determine the true scope and content of this invention.

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